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PATENT
5298-06900/PM01027

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Schwarz

Serial No. 10/074,888

Filed: February 13, 2002

**For: REDUCING DEFECT FORMATION
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SEMICONDUCTOR TOPOGRAPHY**

2025-2026

Group Art Unit: 1765

Examiner: Deo, D.

Atty. Dkt. No. 5298-06900

I hereby certify that this correspondence is being transmitted via facsimile or deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 450, Alexandria, VA 22313, on the date indicated below: *11/1/88*

May 3, 2004
Date

Kevin L. Daffer

AMENDMENT; RESPONSE TO OFFICE ACTION DATED FEBRUARY 3, 2004

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir/ Madam:

This paper is submitted in response to the Office Action dated February 3, 2004 to further highlight reasons why the application is in condition for allowance.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks begin on page 8 of this paper.